



H&A-104

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

K. NAGATA et al

Serial No. 09/924,575

Group Art Unit: 2881

Filed: August 9, 2001

Examiner: L. Nguyen

For: METHOD AND APPARATUS FOR CHARGED
PARTICLE BEAM EXPOSURE

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the telephonic Restriction Requirement
issued by the Examiner, please amend the above-identified
application as follows.

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